

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/072,823	CHEN, SOPHIE	
Examiner	Art Unit	
Michael V. Meller	1655	

Michael V. Meller

SEARCHED				
Class	Supclass	Date /	Examiner	
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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